

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,934,065 B2  
DATED : August 23, 2005  
INVENTOR(S) : Larry D. Kinsman

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page.

Item [56], **References Cited**, U.S. PATENT DOCUMENTS, insert the following:

-- 6,407,381	Glenn et al.	06/18/2002
2004/0038442	Kinsman	02/26/2004
2004/0041261	Kinsman	03/04/2004
10/893,022	Hall et al.	07/16/2004
10/901,851	Derderian et al.	07/28/2004
10/915,180	Street et al.	08/10/2004
10/927,550	Derderian et al.	08/26/2004 --.

OTHER PUBLICATIONS, insert the following:

-- DuPont Electronic Materials, Data Sheet, Pyralux PC 2000 Flexible Composites, 4 pages, October 1998, <<http://www.dupont.com/fcm>>.

Micro Chem, Nano SU-8, Negative Tone Photoresist Formulations 50-100, 4 pages, February 2002, <[http://www.microchem.com/products/pdf/SU8\\_50-100.pdf](http://www.microchem.com/products/pdf/SU8_50-100.pdf)>.

BRUBAKER, C. et al., "Ultra-thick Lithography for Advanced Packaging and MEMS," SPIE's 27<sup>th</sup> Annual International Symposium on Microlithography 2002, March 3-8, 2002, Santa Clara, CA.

Austin, M.D. and S.Y. Chou, "Fabrication of 70 nm channel length polymer organic thin-film transistors using nanoimprint lithography," Applied Physics Letters, Vol. 81, No. 23, pp. 4431-4433, December 2, 2002, American Institute of Physics; --.

Signed and Sealed this

Third Day of January, 2006



JON W. DUDAS  
*Director of the United States Patent and Trademark Office*